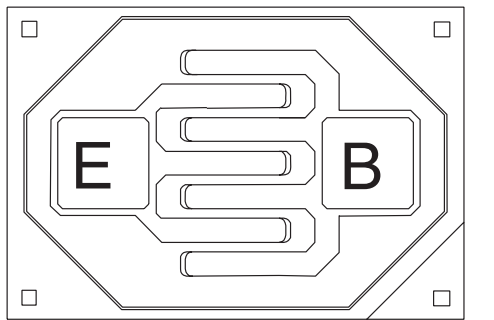


**PROCESS DETAILS**

Process	EPITAXIAL PLANAR
Die Size	13 x 17 MILS
Die Thickness	7.1 MILS
Base Bonding Pad Area	3.0 X 3.0 MILS
Emitter Bonding Pad Area	3.0 X 3.0 MILS
Top Side Metalization	Al - 30,000Å
Back Side Metalization	Au - 18,000Å

**GEOMETRY**



BACKSIDE COLLECTOR

**GROSS DIE PER 4 INCH WAFER**

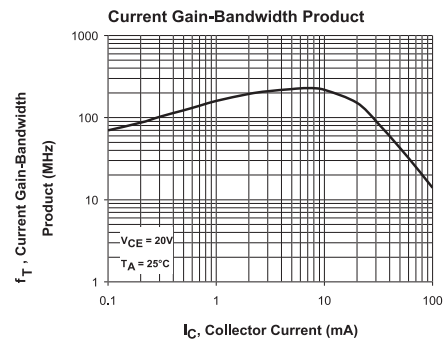
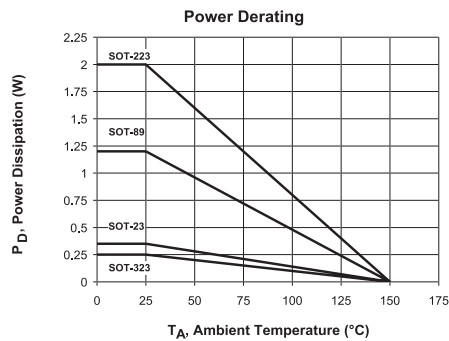
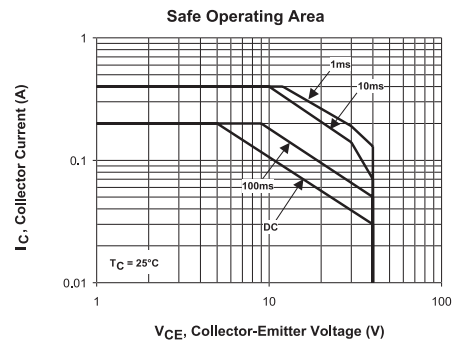
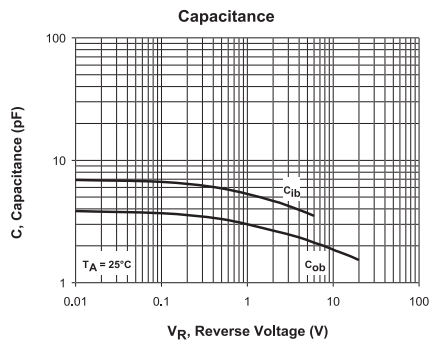
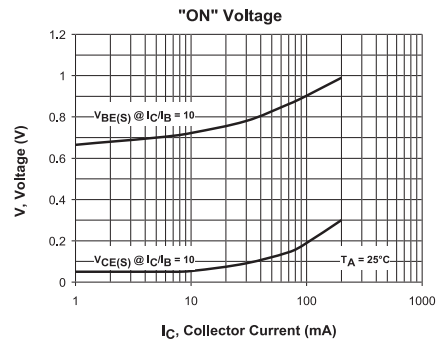
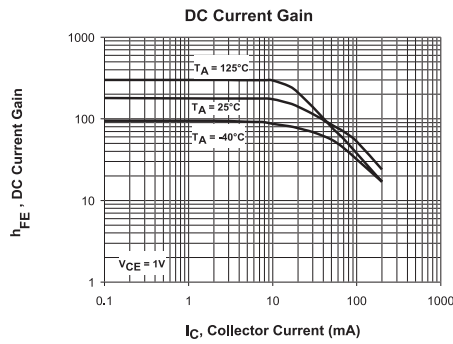
52,920

**PRINCIPAL DEVICE TYPES**

2N3904  
CMKT3904  
CMLT3904E  
CMPT3904  
CMST3904  
CXT3904  
CZT3904

145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centalsemi.com

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